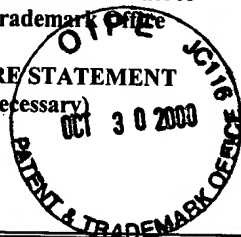


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(Rev. 2-32)U.S. Department of Commerce
Patent & Trademark OfficeAtty. Docket No.
002935 USA/PDC/ICT/DBSerial No.
09/162,103

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant:
Dieter WINKLER et al.Filing Date:
September 28, 1998Group
2881

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
KF	5,122,663	6/16/92	Chang et al.	250	310	
KF	5,155,412	10/13/92	Chang et al.	315	14	

FOREIGN PATENT DOCUMENTS

Document	Date	Country	Class	Sub-class	Translation Yes/No
HEI 11-16967	1/22/99	Japan			Yes

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Chang et al., "Electron beam technology - SEM to microcolumn," <i>Microelectronic Engineering</i> , 32 (1996) pages 113-130.

EXAMINER

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